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|---|---|------------------------|---|-----------------------------------|
| SERIAL NUMBER 10/713,383 | FILING DATE 11/13/2003 RULE | CLASS 117 | GROUP ART UNIT 1722 | ATTORNEY DOCKET NO. SLA0809 |
| APPLICANTS Apostolos T. Voutsas, Vancouver, WA; Robert S. Sposili, Portland, OR; Mark A. Crowder, Portland, OR; ** CONTINUING DATA ***** ** FOREIGN APPLICATIONS ***** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 02/23/2004 | | | | |
| Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> met <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged | STATE OR COUNTRY WA Examiner's Signature _____ Initials _____ | SHEETS DRAWING 3 | TOTAL CLAIMS 18 | INDEPENDENT CLAIMS 3 |
| ADDRESS 27518 DAVID C RIPMA, PATENT COUNSEL SHARP LABORATORIES OF AMERICA 5750 NW PACIFIC RIM BLVD CAMAS, WA 98607 | | | | |
| TITLE Process for long crystal lateral growth in silicon films by UV and IR pulse sequencing | | | | |
| FILING FEE RECEIVED 770 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) | |